



S/N 09/652,713

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Trung T. Doan	Examiner:	Sylvia MacArthur
Serial No.:	09/652,713	Group Art Unit:	1763
Filed:	August 31, 2000	Docket No.:	303.928US5
Title:	CHEMICAL DISPENSING SYSTEM FOR SEMICONDUCTOR WAFER PROCESSING		

AMENDMENT AND RESPONSE UNDER 37 CFR § 1.111

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

This paper responds to the Office Action dated August 19, 2005. Please amend the above-identified patent application as follows.

This response is accompanied by a Petition, as well as the appropriate fee, to obtain a two-month extension of the period for responding to the Office Action, thereby moving the deadline for response from November 19, 2005 to January 19, 2006.